

10/556663

JCOG Rec'd DPT/PTO 11 NOV 2005

Form PTO-1449 (Modified) LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)	<table border="1" style="width: 100%; border-collapse: collapse;"> <tr> <td style="width: 50%;"> Atty Docket No. HARAP0166US </td> <td style="width: 50%;"> Express Mail No. EV710253666US </td> </tr> <tr> <td colspan="2"> Applicant: Morito AKIYAMA, et al. </td> </tr> <tr> <td> Filing Date November 11, 2005 </td> <td> Group Not Yet Assigned </td> </tr> </table>	Atty Docket No. HARAP0166US	Express Mail No. EV710253666US	Applicant: Morito AKIYAMA, et al.		Filing Date November 11, 2005	Group Not Yet Assigned
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U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date MM/YYYY	Name	Class	Sub-class	Filing Date if Appropriate

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS							
Examiner Initial	Document Number	Date MM/YYYY	Country	Class	Sub-class	Translation	
						Yes	No
/DR/	2004-200843	07/2004	JP	Abstract	

OTHER ART

Examiner Initial	Author, Title, Date, Pertinent Pages, etc.
/DR/	International Search Report for corresponding PCT/JP2004/006553, mailed, August 24, 2004.
↓	Morito Akiyama et al.; "Statistical approach for optimizing sputtering conditions of highly oriented aluminum nitride thin films", Thin Solid Films, 1998, Vol. 315, p. 62-65.
↓	Morito Akiyama et al.; "Influence of sputtering target material on crystallinity and orientation of AlN thin films", Journal of the Ceramic Society of Japan, 2002, Vol. 110, p. 115-117.
↓	Mikito Kamijo et al.; "Study of deposition of colored films by sputtering method", No. 14, 2000, p. 31-35.
↓	Yoshihito Maeda et al.; "Direct overwriting in InSbTe phase-change optical disk and the mechanism"; 1988, Vol. 88, No. 388, p. 47-52.
↓	Toshihiro Kamohara, et al.; "Improvement on crystal orientation of AlN thin films by AlN Nanointerlayers", March 28, 2004, No. 1, p. 402, 30p-YN-3.
/DR/	Morito Akiyama et al.; "Improvement on orientation of AlN thin films by Laminated Electrodes", March 27, 2003, No. 2, p. 691, 30a-S-3.

EXAMINER /Derek Rosenau/	DATE CONSIDERED 10/07/2008
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Information Disclosure Statement PTO-1449 (Modified)

The identification of any reference is not intended to be, and should not be understood as being, an admission that such publication, in fact, constitutes "prior art" within the meaning of applicable law since, for example, a given reference may have a later effective date than first seems apparent or the reference may have an effective date which can be antedated. The "prior art" status of any reference is a matter to be resolved during prosecution.